



PATENT Customer No. 22,852 Attorney Docket No. 04329.3115

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re A	Application of:	)
Ryouichi INANAMI et al.		) Group Art Unit: 2825
Application No.: 10/642,680		Examiner: Lin, Sun J.
Filed:	August 19, 2003	) Confirmation No. 2707
For:	METHOD FOR CREATING CHARGED-PARTICLE-BEAM EXPOSURE DATA, METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE, AND PROGRAM	) ) ) ) ) ) )
Comm P.O. B	Stop Amendment hissioner for Patents Box 1450 ndria, VA 22313-1450	
Sir:		

## **AMENDMENT**

In reply to the Office Action mailed August 8, 2005, the period for response to which extends through November 8, 2005, please amend the application as follows.

Amendments to the Specification are set forth beginning on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 8 of this paper.